

<b>Notice of References Cited</b>	Application/Control No. 10/004,197		Applicant(s)/Patent Under Reexamination NEMECEK ET AL.	
	Examiner Jason Proctor		Art Unit 2123	Page 1 of 1

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	V	"Microsoft Files Summary Judgement Motions", February 1999, Microsoft PressPass, retrieved on 5/20/2005 from <a href="http://www.microsoft.com/presspass/press/1999/Feb99/Calderapr.asp">http://www.microsoft.com/presspass/press/1999/Feb99/Calderapr.asp</a> , pages 1-6
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.